



AF/281U *AS IFW*

PATENT
Customer No. 22,852
Attorney Docket No. 08245.0027

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Jun Dong KIM et al.) Group Art Unit: 2814
Application No.: 09/892,878) Examiner: Rao, Shrinivas H.
Filed: June 28, 2001)
For: METHOD FOR FORMING GATE)
ELECTRODES IN A)
SEMICONDUCTOR DEVICE USING)
FORMED FINE PATTERNS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one-month extension of time to reply to the Office Action of March 31, 2004. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: July 29, 2004

By: 
Michael Kelly
Reg. No.: 33,921

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